DOCKET NO: 292134US26PCT

## IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :

MASARU SASAKI, ET AL. : EXAMINER: NIKMANESH, S. J.

SERIAL NO: 10/581,601 :

FILED: JUNE 5, 2006 : GROUP ART UNIT: 2812

FOR: METHOD OF CLEANING SEMICONDUCTOR SUBSTRATE CONDUCTIVE LAYER SURFACE

## AMENDMENT UNDER 37 C.F.R. § 1.114

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated December 12, 2008, please amend the aboveidentified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 6 of this paper.